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	Application No.	Applicant(s)	
Notice of Allowability	10/707,299	CHEN ET AL.	
	Examiner	Art Unit	
	Elizabeth A. Rielley	2879	
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIC of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in a or other appropriate commur GHTS. This application is su	this application. If not included nication will be mailed in due cours	se. THIS
1. 🔀 This communication is responsive to <u>amendment filed on 9.</u>	<u>/22/2005</u> .		
2. The allowed claim(s) is/are <u>1-15</u> .			
 3. Acknowledgment is made of a claim for foreign priority units. a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 		(f).	
2. Certified copies of the priority documents have	been received in Application	No	
Copies of the certified copies of the priority doc	uments have been received	in this national stage application for	rom the
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" on noted below. Failure to timely comply will result in ABANDONMITHIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a ENT of this application.	reply complying with the requirer	nents
4. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which gives	tted. Note the attached EXAN s reason(s) why the oath or c	MINER'S AMENDMENT or NOTIC declaration is deficient.	E OF
5. CORRECTED DRAWINGS (as "replacement sheets") must	be submitted.		
(a) \square including changes required by the Notice of Draftsperso		(PTO-948) attached	
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date		•	
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	Amendment / Comment or in	n the Office action of	
Identifying indicia such as the application number (see 37 CFR 1.6 each sheet. Replacement sheet(s) should be labeled as such in th	84(c)) should be written on the e header according to 37 CFR	drawings in the front (not the back 1.121(d).) of
 DEPOSIT OF and/or INFORMATION about the depos attached Examiner's comment regarding REQUIREMENT F 	it of BIOLOGICAL MATER	RIAL must be submitted. Note t	he
Attachment(s) 1. Notice of References Cited (PTO-892)	5. ☐ Notice of Info	rmal Patent Application (PTO-152	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Sun		'
	Paper No./M	ail Date .	
 Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date 	B), 7. ∐ Examiner's A	mendment/Comment	
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛭 Examiner's Si	latement of Reasons for Allowanc	e
	9. 🗌 Other		

DETAILED ACTION

Response to Amendment

Amendment filed 9/22/2005 has been entered and considered by the Examiner. Claims 12-15 have been added. Currently, claims 1-15 are pending in the instant application.

Allowable Subject Matter

Claims 1-15 are allowed.

Regarding claim 1, the reference of the Prior Art of record fails to teach of suggest the combination of the limitations as set forth in claim 1, and specifically comprising the limitation an organic light emitting device, comprising; a first mixing layer formed over an anode layer, wherein a material of the first mixing layer is a mixture of a hole transport material and an electron transport material; a mixing layer formed on the first mixing layer; wherein a material of the mixing layer is a mixture of an organic light emitting material, the hole transport material and the electron transport material; a second mixing layer formed on the mixing layer, wherein a material of the second mixing layer is a mixture of the hole transport material and the electron transport material; and a cathode layer formed over the second mixing layer; wherein, when a volume ratio of the hole transport material to the electron transport materials in the mixing layer is X %, a volume ratio of the hole transport material to the electron transport materials in the first mixing layer decreases gradually from 99% to X % starting from a surface adhered to the anode layer, wherein a volume ratio of the hole transport material to the electron

transport material in the second mixing layer increases gradually from X % to 99% starting from a surface adhered to the mixing layer.

Regarding claims 2-6, claims 2-6 are allowable for the reasons given in claim 1 due to their dependency status from claim 1.

Regarding claim 7, the reference of the Prior Art of record fails to teach of suggest the combination of the limitations as set forth in claim 7, and specifically comprising the limitation an organic light emitting device comprising: a hole transport layer formed over an anode layer; a mixing layer formed on the hole transport layer; wherein a material of the mixing layer is a mixture of an organic light emitting material, a hole transport material and an electron transport material, wherein a volume ratio of the hole transport material to the electron transport material in the mixing layer decreases gradually from 99% to 1% from the surface adhered to the hole transport layer; a second mixing layer comprising a mixture of an electron transport material and a hole transport material formed on the mixing layer; and a cathode layer formed over the electron transport layer.

Regarding claims 8-11, claims 8-11 are allowable for the reasons given in claim 7 due to their dependency status from claim 7.

Regarding claim 12, the reference of the Prior Art of record fails to teach of suggest the combination of the limitations as set forth in claim 12, and specifically comprising the limitation an organic light emitting device comprising; a hole transport layer formed over an anode layer; a mixing layer formed on the hole transport layer; wherein a material of the mixing layer is a mixture of an organic light emitting material, a hole transport material and an electron transport material, wherein a volume

ratio of the hole transport material to the electron transport material in the mixing layer decreases gradually from 99% to 1% from the surface adhered to the hole transport layer; a second mixing layer comprising a mixture of an electron transport material and a hole transport material formed on the mixing layer; an electron injection layer between the second mixing layer and the cathode layer; a nd a cathode layer formed over the electron transport layer.

Regarding claims 13-15, claims 13-15 are allowable for the reasons given in claim 12 due to their dependency status from claim 12.

Response to Arguments

Applicant's arguments, see amendment, filed 9/22/2005, with respect to claims 1-11 have been fully considered and are persuasive. The rejection of claims 1-11 has been withdrawn.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Elizabeth A. Rielley whose telephone number is 571-272-2117. The examiner can normally be reached on Monday - Friday 7:30 - 4:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nimeshkumar Patel can be reached on 571-272-2457. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Elizabeth Rielley

Examiner Art Unit 2879 MARICELI SANTIAGO